



Serial No. 09/689,814

SEC.760

Amendment dated 10/23/2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:

Seung-pil Chung et al.

Group Art Unit: 1763

Serial No.: 09/689,814

Examiner: L. Alejandro Mulero

Filed: 13 October 2000

METHOD FOR REMOVING OXIDE  
LAYER AND SEMICONDUCTOR  
MANUFACTURING APPARATUS  
FOR REMOVING OXIDE LAYER

**REQUEST FOR RECONSIDERATION**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

In response to the Office Action dated 25 June 2003, the period for response to which is hereby being extended by the accompanying Petition and Petition Fee to 25 October 2003, please amend the above-identified patent application as follows:

**Remarks begin on page 2 of this paper.**

**RECEIVED**  
OCT 28 2003  
**TC 1700**